



**ELECTRONIC COPY**

LG750539348  
Report verification at igi.org

**LABORATORY GROWN DIAMOND REPORT**

November 21, 2025  
IGI Report Number **LG750539348**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **9.37 X 6.87 X 4.80 MM**

**GRADING RESULTS**

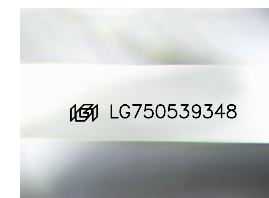
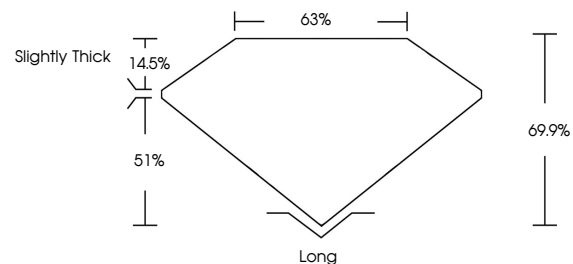
Carat Weight **3.04 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG750539348**

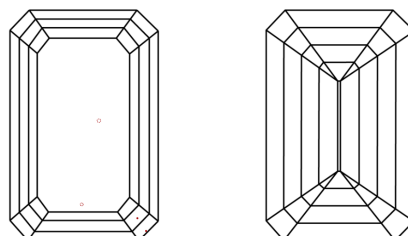
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

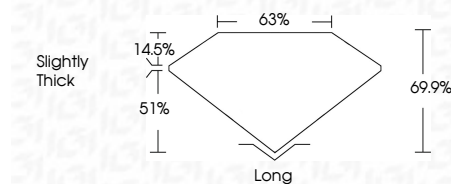
D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



November 21, 2025  
IGI Report No LG750539348  
**EMERALD CUT**  
3.04 CARATS  
Color Grade **F**  
Clarity Grade **VVS 2**  
Table **63%**  
Depth **51%**  
Girdle **Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG750539348**

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